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ocket No.: 50099-238

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
	:	
Shigenobu MAEDA, et al.	:	Confirmation Number: 6603
	:	
Serial No.: 10/748,273	:	Group Art Unit: 2811
	:	
Filed: September 2, 2004	:	Examiner:
	:	
For:		METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING IMPURITY REGION UNDER ISOLATION REGION (AS AMENDED)

**SUPPLEMENTAL PRELIMINARY AMENDMENT**

Mail Stop Preliminary Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: